

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 20277  
: :  
Mitsumi ITO, et al. : Confirmation Number:  
: :  
Serial No.: : Group Art Unit:  
: :  
Filed: August 06, 2003 : Examiner:  
: :  
For: SEMICONDUCTOR DEVICE, METHOD OF GENERATING PATTERN FOR  
SEMICONDUCTOR DEVICE, METHOD OF MANUFACTURING SEMICONDUCTOR  
DEVICE AND DEVICE OF GENERATING PATTERN USED FOR SEMICONDUCTOR  
DEVICE

**CLAIM OF PRIORITY**

Mail Stop CPD  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

**Japanese Patent Application No. 2002-229215, filed August 6, 2002**

cited in the Declaration of the present application. A certified copy will be filed in due course.

Respectfully submitted,

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